



Practitioner's Docket No.: 791_202 NP

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of: Nobuo TAKAHASHI, Yuki BESSHO, Nobuyuki KOBAYASHI and
Masahiro MURASATO

Serial No.: 10/615,545

Art Unit: Not assigned

Date Filed: July 8, 2003

Examiner: Not assigned

Confirmation No.: Unknown

For: **PIEZOELECTRIC/ELECTROSTRICTIVE FILM DEVICE, AND
MANUFACTURING METHOD OF THE DEVICE**

Mail Stop Missing Parts
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with
the United States Postal Service as first class mail addressed to
Mail Stop Missing Parts, Commissioner for Patents, P.O.
Box 1450, Alexandria, VA 22313-1450 on August 11, 2003.

Janet M. Stevens

**TRANSMITTAL OF ENGLISH TRANSLATION
OF NON-ENGLISH LANGUAGE *PROVISIONAL* APPLICATION
UNDER 37 CFR §1.78(a)(5)**

Sir:

Applicants submit herewith an English translation of non-English language Provisional
Application Serial No. 60/395,503, filed July 12, 2002 wherein the present application claims
§119(e) priority of said non-English language provisional application (as noted in the Patent
Application Bibliographic Data Sheet filed in the present application on Concurrently Herewith).
Also submitted herewith is a statement by the translator that the translation is accurate.

Respectfully submitted,

August 11, 2003

Date

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**NOTE: The attached translation is a translation of the Japanese-language
Provisional Application from which priority is claimed in the present Non-
Provisional Application.**



VERIFICATION OF TRANSLATION

I, Kazuhira Watanabe, state that I am fluent in the English language and in the Japanese language. I hereby verify that the attached English language translation of US Provisional Patent Application Serial No.60/395,503 entitled PIEZOELECTRIC/ELECTROSTRICTIVE FILM TYPE DEVICE, AND MANUFACTURING METHOD OF THE DEVICE is a true and correct translation to the best of my knowledge and belief.

Signed this 5th day August, 2003

By 
Kazuhira Watanabe